

<b>Search Notes</b> 	<b>Application/Control No.</b> 10/749,396	<b>Applicant(s)/Patent under Reexamination</b> YAMAMOTO, TAKESHI
<b>Examiner</b> Wen-Ying P. Chen	<b>Art Unit</b> 2871	

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner